

CV

Docket No. F-9089

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Joachim MAI, et al.
Serial No. : 10/578,047
Filed : August 7, 2007
For : METHOD AND DEVICE FOR ION BEAM
PROCESSING OF SURFACES
Group Art Unit : 1795
Examiner : Rodney Glenn McDonald
Confirmation No. : 5426
Customer No. : 000028107

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C. Bruce Hamburg
(Name)


(Signature)

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action of September 8, 2010 please amend the above-identified patent application as follows: